



**EV372461036**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 10/071,425  
Filing Date ..... February 8, 2002  
Confirmation No. .... 1727  
Inventor ..... Terry L. Gilton  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Thanhha S. Pham  
Attorney's Docket No. .... MI22-1828  
Customer No. .... 021567  
Title: Semiconductor Processing Method Using Photoresist and an Antireflective  
Coating

**RESPONSE AFTER JUNE 29, 2004 NOTICE OF ALLOWANCE**  
**PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING**

To: Mail Stop RCE  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**VIA EXPRESS MAIL**

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 West First Avenue, Suite 1300  
Spokane, WA 99201-3828

Responsive to the Notice of Allowance dated June 29, 2004, Applicant  
remarks as follows:

**AMENDMENTS**